

Notice of References Cited	Application/Control No. 10/649,099	Applicant(s)/Patent Under Reexamination TANG ET AL.	
	Examiner Mahmoud Dahimene	Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,661,083	08-1997	Chen et al.	438/637
*	B	US-2004/0157444	08-2004	Chiu et al.	438/689
*	C	US-6,156,485	12-2000	Tang et al.	430/313
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf and R.N. Ttauber, Silicon Processing for the VLSI Era, Volume 1- Process Technology, Lattice Press, 1986 (PAGES 546-547)
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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